

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Yuen et al.	Group Art Unit: 1763
Application No.: 09/718,319	Examiner: George A. Goudreau
Confirmation No.: 3056	Attorney Docket No.: 004704 USA/ETCH/SILICON/JB1
Filing Date: November 21, 2000	October 30, 2003 San Francisco, California
Title: ETCHING A SUBSTRATE IN A PROCESS ZONE	

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AMENDMENT UNDER 37 C.F.R. 1.111

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Examiner Goudreau:

This communication is in response to the Non-Final Office Action mailed on July 30, 2003, and is being timely filed within three months thereof.

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By <u>Stephen Guzzi</u>	Date: <u>October 30, 2003</u>